



PATENT

Case Docket No. ASMJP.055AUS

Date: June 4, 2003

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Satoh et al.  
Appl. No. : 09/764,523  
Filed : January 18, 2001  
For : A SEMICONDUCTOR  
PROCESSING DEVICE  
PROVIDED WITH A REMOTE  
PLASMA SOURCE FOR SELF-  
CLEANING  
Examiner : Rudy Zervigon  
Group Art Unit : 1763

I hereby certify that this correspondence and any  
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United States Postal Service as first class mail in  
an envelope addressed to: Commissioner for  
Patents, P.O. Box 1450, Alexandria, VA 22313-  
1450, on

June 4, 2003

(Date)

*Adeel S. Akhtar*  
Adeel S. Akhtar, Reg. No. 41,394

## TRANSMITTAL LETTER

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application are:

- (X) A Response to Restriction Requirement.
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.
- (X) Return prepaid postcard.

*Adeel S. Akhtar*  
Adeel S. Akhtar  
Registration No. 41,394  
Attorney of Record  
Customer No. 20,995  
(415) 954-4114



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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GROUP 1700

Applicant	:	Satoh et al.	)	Group Art Unit 1763
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Filed	:	January 18, 2001	)	the United States Postal Service as first-class
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For	:	A SEMICONDUCTOR	)	Commissioner for Patents, P.O. Box 1450,
		PROCESSING DEVICE	)	Alexandria, VA 22313-1450, on
		PROVIDED WITH A REMOTE	)	
		PLASMA SOURCE FOR	)	
		SELF-CLEANING	)	
			)	
Examiner	:	Rudy Zervigon	)	

June 4, 2003

(Date)

*Adeel S. Akhtar*  
Adeel S. Akhtar, Reg. No. 41,394

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

#9  
6/14/03  
mm

Dear Sir:

**Response to Restriction Requirement**

In an action mailed May 29, 2003, the Examiner required restriction of prosecution to one of the following groups of claims:

- |          |  |
|----------|--|
| Group I  | Claims 41-44, drawn to a chemical vapor deposition device, classified in class 118, subclass 723ER; and                        |
| Group II | Claims 33-40, and 45, drawn to a method of cleaning a chemical vapor deposition device, classified in class 134, subclass 1.1. |

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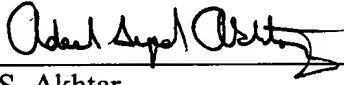
In response, Applicants elect, without traverse, to proceed with examination on the merits of Group II (Claims 33-40, and 45), drawn to a method of cleaning a chemical vapor deposition device, classified in class 134, subclass 1.1.

In view of the foregoing, Applicants submit that the application is in condition for examination on the merits and respectfully request the same.

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: June 4, 2003

By:   
Adeel S. Akhtar  
Registration No. 41,394  
Attorney of Record  
Customer No. 20,995  
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